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Tip Recycling for Atomic Force Microscopy-Based Tip-Enhanced Raman Spectroscopy

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Abstract

Tip-Enhanced Raman Spectroscopy (TERS) is a powerful tool for the characterization of surfaces and 2D materials, delivering both topographical and chemical information with nm-scale spatial resolution. AFM-TERS combines an atomic force microscope (AFM) with a Raman spectrometer and is a very versatile technique, capable of working in vacuum, air and liquid, and on a variety of different samples. A metalized AFM tip is necessary in order to take advantage of the plasmonic enhancement. The most commonly used metal is Ag, thanks to its high plasmonic activity in the visible range. Unfortunately, though, the tip metallization process is still challenging and not fully reliable, yielding inconsistent enhancement factors even within the same batch of tips; as a consequence, many tips are usually prepared at once (for a single experiment), to ensure that at least one of them is sufficiently active. As the lifetime of an unprotected, Ag-coated plasmonic probe is only a few hours, the procedure is inefficient and results in a substantial waste of materials and money. In this work, we establish a cleaning routine to effectively re-use Ag-coated AFM-TERS probes, drastically reducing costs without compromising the quality of the experimental results.

Introduction

Tip-enhanced Raman spectroscopy (TERS) is an analytical technique which combines scanning probe microscopy (such as Scanning Tunneling Microscopy - STM or Atomic Force Microscopy – AFM) with Raman spectroscopy with the aim of obtaining a vibrational spectrum from very small spots of the sample, well below the optical diffraction limit. It was independently demonstrated by four different
laboratories in 2000\textsuperscript{1–4} and has proven very effective for nanoscale characterization of surfaces; recently, a resolution as low as 1.7 nm was shown in ambient conditions\textsuperscript{5}, while sub-molecular resolution was achieved in ultra-high vacuum\textsuperscript{6}. STM-TERS has established itself as a valuable tool for the investigation of 2D materials\textsuperscript{7} but requires the substrate to be conductive. Moreover, the sample thickness should allow the current to tunnel through (practically, $< 5$ nm)\textsuperscript{8}. AFM-TERS, on the other hand, is more versatile, since it is neither substrate-sensitive nor limited by the sample thickness and can thus be used for a much wider variety of applications, e.g. the characterization of biological membranes or dielectric materials\textsuperscript{9}. Experiments were successfully performed on lipids\textsuperscript{10}, DNA\textsuperscript{11} and proteins\textsuperscript{12}, even in a liquid environment\textsuperscript{13} with AFM-TERS. The heart of every AFM-TERS experiment is an enhancing plasmonic probe; commercially available AFM cantilevers, usually made of Si, need to be metalized to become suitable as TERS probes. Many tip fabrication methods have been investigated so far, including electrodeposition\textsuperscript{14}, electroless deposition\textsuperscript{15} or the attachment of Ag nanowires to the cantilever\textsuperscript{16}, but the most common functionalization method is the deposition of a thin layer of plasmonic metal (generally Ag or Au) via physical vapor deposition (PVD). Despite being widespread and effective, the PVD coating process requires several hours and an expensive vacuum setup. Conversely, the average operational lifetime of an unprotected Ag-coated plasmonic tip is less than 5 hours in ambient conditions\textsuperscript{17}. Furthermore, as the plasmonic activity of probes can greatly vary (some tips may simply not be active at all), it is common practice for every experimental measurement to prepare 3 to 5 tips just as a backup. At the end of their life cycle, whether used or not, metalized tips are discarded as they are no longer enhancing and possibly contaminated with carbonaceous species from the environment. Considering their high cost (up to a hundred dollar each) and the long time it takes to prepare them, the current procedure is neither time nor economically efficient. The possibility to recycle tips is thus attractive from two points of view: first, reusing probes represents an obvious economic advantage; second, defining a consistent cleaning routine would possibly help tackling another major problem of TERS, i.e. environmental contamination. In fact, even though the technique developed dramatically in the last years, contamination from the environment, resulting in inconsistent and spurious spectra, is a key issue the TERS community has been facing since the earliest experiments and is yet to be fully resolved\textsuperscript{18}. An acceptable procedure will allow the restoration the tip to a pristine condition, removing all the silver
and leaving the Si structure intact, ready to be coated again. In this project, several
approaches were investigated with the goal of establishing an effective workflow for
the recycling of Ag-coated AFM-TERS tips. Selective removal of the metal coating was
achieved, without compromising the underlying silicon structure. Recycled tips were
studied using SEM and AFM and showed no significant difference in structural
features and spatial resolution compared to brand new ones. Most importantly, TERS
experiments on test samples exhibited no deviation from reference spectra, confirming
the reliability of the approach. These results pave the way to a cheaper and more
efficient probe preparation protocol that could easily be implemented in other
laboratories.

**Results and Discussion**

First, different cleaning mixtures were tested in order to verify the effectiveness of Ag
removal as well as their ability to leave the underlying Si structure untouched. A total
of 7 cleaning baths were selected (Table 1) and each one of them was tested on 4
tips. Since Ag is a noble metal, the presence of an oxidizing agent was required in all
the mixtures. The evaluation of the result was based on SEM experiments (secondary
electrons (SE) for observing of the tip apex, backscattered electrons (BSE) for
qualitative identification of residual Ag) and on energy dispersive X-ray (EDX) spectra
for the quantification of residual Ag. SEM images are available in supporting
information (Figure S1).

<table>
<thead>
<tr>
<th>Cleaning mixture</th>
<th>Exp. Time (s)</th>
<th>Ag removal</th>
<th>Damage</th>
</tr>
</thead>
<tbody>
<tr>
<td>18M H₂SO₄: 10M H₂O₂ = 3:1</td>
<td>30</td>
<td>Low</td>
<td>High</td>
</tr>
<tr>
<td>9M H₂SO₄: 3 M H₂O₂ = 3:1</td>
<td>60</td>
<td>Low</td>
<td>High</td>
</tr>
<tr>
<td>16M HNO₃</td>
<td>30</td>
<td>High</td>
<td>High</td>
</tr>
<tr>
<td>4M HNO₃</td>
<td>60</td>
<td>Low</td>
<td>Low</td>
</tr>
<tr>
<td>18M NH₃: 10M H₂O₂ = 3:1</td>
<td>30</td>
<td>High</td>
<td>High</td>
</tr>
<tr>
<td>4M NH₃, 1M H₂O₂</td>
<td>1800</td>
<td>High</td>
<td>Low</td>
</tr>
<tr>
<td>O₃ + 4M NH₃, 1M H₂O₂</td>
<td>900 + 30</td>
<td>High</td>
<td>None</td>
</tr>
</tbody>
</table>

Table 1: Mixtures selected for the cleaning process. Composition, exposure time and
performances of all the protocols are presented here.
Piranha solution etching (18M H₂SO₄ : 10M H₂O₂ = 3:1) is well known as a fast and effective way to remove residual traces of organic contaminations (e.g. photoresists) from surfaces. In our case, it would serve the double function of removing both Ag and organic contaminants from the Si surface, making the substrate ready for a second deposition. Unfortunately, the damage to the Si structure of the tip after just 30 seconds of exposure was considerable while the removal of Ag was very limited; for these reasons, the method cannot be considered effective (Figure 1). The degradation mechanism of Si (and of the silicon oxide layer on the surface) when exposed to sulfuric acid is not clear (acids should not be able to etch silicon) and, to the best of our knowledge, has never been reported in literature. A second cleaning attempt, using diluted piranha solution, showed again heavy damage to the tip surface, yet it was not able to completely remove the silver layer. Nitric acid appeared to be a good alternative considering its ability to dissolve silver (HNO₃ is an oxidizing acid) and was tested in two concentrations: 16 M and 4 M. In the case of concentrated (16 M) nitric acid, the Si surface was severely compromised, but the coating layer was fully removed. On the other hand, diluting the acid was a “double-edged sword”; damage to the tip apex was reduced while the Ag removal efficiency was going down.

Figure 1: SEM images and schematic representation of Ag-coated AFM tips treated with: a) 18M H₂SO₄ : 10M H₂O₂ = 3:1, b) 16 M HNO₃ and c) O₃ + 4M NH₃, 1M H₂O₂. Silver removal efficiency is high in b) and c) as the surface is smooth and clean. On
the other hand, aggressive chemicals can irreversibly damage the apex, as in a) and b). Treatment c) is the best compromise in terms of efficiency and selectivity. Scale bars: a) 2 µm, b) 3 µm, c) 300 nm

“Base piranha” etching (18 M NH₄OH: 10 M H₂O₂ = 3:1) was tested then. It is strongly oxidizing, and the formation of the [Ag(NH₃)₂]⁺ complex helps solubilizing the silver quickly. However, the mixture is also very alkaline, favouring the dissolution of silica via the formation of silicilic acid (H₄SiO₄) and silicates (SiO₃⁻). As a consequence, silver was removed very effectively but the tip apex was severely affected. Reducing the concentration of the species (using 4M NH₃ and 1M H₂O₂) resulted in almost no damage to the silicon and in a lower efficiency of the removal process, again not an acceptable result. In order to obtain a quantitative removal, it was necessary to increase the exposure time to 1800 seconds (30’), but at this point silicon was being etched again. We decided to test a pre-oxidation step with ozone (15 minutes) to improve Ag removal. Exposing the tips to an ozone treatment before the wet chemistry process dramatically improved the performances of the subsequent cleaning, reducing the time required in the etching bath to 30 seconds, thus limiting the damage to the underlaying Si structure, from now on we refer to this procedure as Oz-BP (ozone + base piranha, last line in table 1). The SEM image acquired after Oz-BP shows that the apex is still sharp and undamaged while EDX spectroscopy confirms complete removal of Ag from the surface (Figure S2). The coating-cleaning process was repeated 3 times in a row on the same set of tips in order to study possible long-term damage of Oz-BP. Tips were analysed with SEM after every step to constantly monitor their structure. After each cleaning process, we observe that the Ag coating is quantitatively removed, but the tip is covered by an unknown contamination (Figure S3). BSE images clearly show the presence of carbon at the apex (Figure S4), most probably as a result of the electron beam of the microscope itself. To confirm this hypothesis, the tips were imaged by SEM only at the beginning and at the end of a 3-cycle round. As can be seen in Figure 2c-d, almost no deposition of carbon was observed and the tip apex appeared clean and sharp, proving the carbon contamination is an artefact of SEM imaging.
Figure 2: a) carbon build-up on the tip apex (see SI). The size of the tip apex tends to slightly increase as a result of carbon deposits. In any case, the diameter of a cleaned tip is always smaller than a coated one. By limiting high-energy electron exposure, this phenomenon can be significantly reduced: in this case, a tip is imaged just at the start (c) and after three full coating-cleaning cycles (d), showing almost no carbon deposition. In b) a limited shift of the resonance frequency of the tip is observed; this just happened at the end of the first cleaning cycle and may be due to the oxidation of the Si surface. Scale bars in c and d: 300 nm.

Interestingly, after the first cleaning cycle the resonance frequency of the cantilever shifted to a slightly lower value (less than 1%, see Figure 2b). This phenomenon occurred consistently on every tip tested. According to the equation (1), and assuming the elastic constant $k$ did not change in the process, the resonance shift can be attributed to a slight mass ($M$) increase; a reasonable explanation is the oxidation of exposed silicon (the tips are not back-coated with metal). This would also explain why the phenomenon is only observed once, even if the tip undergoes three cleaning cycles.
\[ \nu = \frac{1}{2\pi} \sqrt{\frac{k}{M}} \quad (1) \]

All probes were tested on a sample consisting of single-walled carbon nanotubes (SWCNTs) on template-stripped gold (TSAu). Nanotubes were correctly identified using their diameter (~2 nm, equal to their height in the AFM image) as a reference. Then the resolution, defined as full width at half maximum of their Gaussian profile, was recorded. Spatial resolution (in the plane of the surface) was generally lower than expected because of convolution effects (Figure 3); nonetheless, no worsening was observed, even after 3 cleaning cycles. These results confirm that our cleaning protocol does not damage the structure or the tip of the AFM cantilever.

Figure 3: AFM height image and extracted profile of a SWCNT on TSAu with a brand-new tip (a) and with a recycled one (b). Even after three cleaning cycles the tip does not show any loss in resolution (FWHM for a = 22.5 nm, FWHM for b = 21.4 nm).
Lastly, TERS was tested using the recycled tips. As reference sample, a 4-biphenyl-thiol (4-BPT) self-assembled monolayer (SAM) on TSAu was used. The activity of a set of 4 tips was tested throughout three recycling cycles (4 acquisitions in total). The activity of tips was evaluated by measuring the signal-to-noise ratio between the peak at 1079 cm\(^{-1}\) (in-plane scissoring of C-H bond) and the standard deviation of the noise in the region 1730 – 1880 cm\(^{-1}\), according to the following formula (2):

\[
S/N = \frac{I_{\text{tip}(n)}}{\text{RMS}_{\text{noise}}} \tag{2}
\]

Where S/N is the signal-to-noise ratio, \(I_{\text{tip}(n)}\) is the intensity with a specific tip at 1079 cm\(^{-1}\), \(\text{RMS}_{\text{noise}}\) is the root mean square of the noise, acquired between 1730 and 1880 cm\(^{-1}\). The 1079 cm\(^{-1}\) band was selected because it is specific for 4-BPT and is located in a clean region of the spectrum, while the noise was acquired in a silent region of the spectrum. The peak was fitted with a Gaussian function to obtain the peak intensity. Since a 4-BPT SAM does not exhibit any far-field spectrum, all the signal collected was considered as resulting from near-field. In Figure 4a an AFM-TERS tip was used to measure a spectrum (10 s, 50 µW) in every phase of the process. The first deposition yielded a weakly enhancing tip, while in the second deposition the tip was almost non-active. However, the tip resulted active and strongly enhancing after the third and fourth coating. The three other tips prepared in the same batch (Figure 4b), all follow the same trend.
Figure 4: a) TERS spectra of a 4-biphenylthiol self-assembled monolayer acquired with the same AFM probe coated four different times. The characteristic bands of 4-BPT (1079, 1282, 1588 and 1599 cm\(^{-1}\)) are highlighted. The peak of silicon (521 cm\(^{-1}\)) is also highlighted and used to calibrate the spectrum. b) Quantification of the peak area (for the 1079 cm\(^{-1}\) peak) for four tips after each coating step; despite a very high variability among different tips, recycled probes could be as good as (or potentially better) than new ones. c) Average peak area per coating cycle; the coating process seems to play a major role in defining the enhancing capability of probes.

This result clearly shows that there is no correlation between the number of recyclings and the near field signal, which varies greatly among tips. This finding is in full agreement with what one experiences with new AFM tips, as quite some variability is always observed. However, analysing the average S/N of the four tips per coating
step, a correlation is apparent; when one probe is strongly enhancing, all other probes of the same batch tend to be active. Considering the limited amount of data, one can only speculate that the defining step of the process is the metal deposition. A small change during this phase (e.g. operating pressure of the coating chamber, position of the metal source relative to the tips...) could affect all the tip of the same batch. Even when recycled tips show carbon contaminations, as visible in Figure 4a, coating 3, the number of recyclings does not correlate with the intensity of carbon contaminations signals. In some cases, the opposite may be true, as seen in Figure S5, where the spurious signal arising from contamination decreased throughout the cleaning/coating cycles (from 1 to 4) and the spectrum of 4-BPT become better defined. It could be due to the strong oxidizing power of the Oz-BP procedure. This calls for a more detailed study of the effect of recycling on contamination in ambient TERS, which is out of the scope of the work presented here.

**Conclusion**

We successfully implemented a protocol for recycling used Ag-coated AFM-TERS tips. By selecting the best wet-chemistry approach, rapid and effective removal of the silver coating was achieved, while damage to the silicon tip was avoided. Most importantly, recycled tips perform as well as brand new ones in TERS experiments, making it possible for laboratories to make better use of their resources, and perform AFM-TERS experiments more efficiently.

**Experimental section**

Sulfuric acid (98%), nitric acid (65%), hydrogen peroxide (30%), ammonium hydroxide (35%), and 4-biphenyl thiol were purchased from Sigma Aldrich (St. Louis, MO, USA) and used without further purification. Solutions were diluted with distilled water. ATEC-NC cantilevers (NanoAndMore GmbH, Wetzlar, Germany) were used as test probes for all the experiments. A special holder was designed to facilitate the handling, coating, cleaning and imaging of the probes. To compensate for the angle of the tip, an offset of 39° was imposed by tilting the tip holder (further details are available in SI, Figure S6). Tips were coated with silver (99.95%, Alfa Aesar, Haverhill, MA, USA) up to 35 nm nominal thickness via physical vapor deposition at a pressure <10^{-6} mbar. For this purpose, a Baltec MCS 010 evaporator equipped with a Baltec QSG 060
quartz balance was used. The UV-O₃ cleaner used in these experiments was from Ossila Ltd, Sheffield, UK. Scanning electron microscope images were acquired using a Hitachi SU5000 or SU8200 (Hitachi Ltd., Tokyo, Japan) instrument. Unless otherwise specified, for secondary electron (SE) imaging, an acceleration voltage of 10 kV and a current intensity of 5 nA was applied, whereas for backscattered electron (BSE) imaging, the acceleration voltage was increased to 15 kV and the current intensity to 30 nA. For energy-dispersive X-ray spectroscopy (EDX), a Hitachi SU8200 (Hitachi Ltd., Tokyo, Japan) instrument was used: the voltage was set to 10 kV, the current intensity to 50 nA, and the signal was acquired with a X-MaxN 80T (Oxford Instruments plc, Abingdon, UK) detector. AFM data were acquired on a Bioscope Catalyst (Bruker Corporation, Billerica, MA, USA). Both AFM and SEM images were processed with Gwyddion software (gwyddion.net). TERS experiments were performed on a Ntegra Spectra II (NT-MDT Spectrum Instruments, Zelenograd, Russia), equipped with a 632.8 nm He-Ne laser. Spectral data were analysed and plotted with a custom-made Python routine. Additional details about procedures and preparation of the samples could be found in SI.

Notes

The original data used in this publication are made available in a curated data archive at ETH Zurich (https://www.research-collection.ethz.ch) under the DOI 10.3929/ethz-b-000396976

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References


